



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Yun-woo NAM et al.

Art Unit: 1765

Serial No. 10/669,360

Examiner: Lan Vinh

Filed: September 25, 2003

Confirmation No. 3357

For: FLEXIBLE MEMS TRANSDUCER  
MANUFACTURING METHOD

Attorney Docket No. 277/017

OK to enter

LV

7/21/06

**SUPPLEMENTAL AMENDMENT UNDER 37 C.F.R. § 1.114**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In connection with the Request for Continued Examination filed on May 22, 2006, and further to a personal interview conducted with Examiner Lan Vinh on June 19, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

**Amendments to the Claims** are reflected in a listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 9 of this paper.